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Date

PATENT APPLICATION

Inventor(S)	Yuanning Chen Sundar Srinivasan Chetlur Pradip K. Roy	Case	4-17-157
Serial No.	09/597076	Group Art Unit	2812
Filing Date	06/20/2000	Examiner	Not yet assigned
Title	Process For Fabricating Oxides		

THE COMMISSIONER OF PATENTS AND TRADEMARKS
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SIR:

INFORMATION DISCLOSURE STATEMENT
CERTIFICATION UNDER 37 CFR 1.97

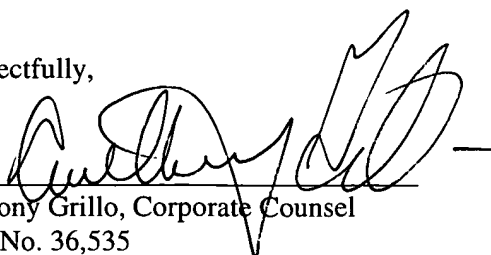
In accordance with 37 CFR 1.97 (c), the enclosed Information Disclosure Statement, with attached reference (s), is submitted for consideration in the above-identified application.

I certify that each item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. Copies of the listed documents are enclosed together with the search report that listed these documents.

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By 
Anthony Grillo, Corporate Counsel
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Agere Systems Inc.

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Att.
Information Disclosure Statement with attachment(s)

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